

<p align="center">Notice of References Cited</p>	Application/Control No. 10/632,247	Applicant(s)/Patent Under Reexamination LIM ET AL.	
	Examiner Denise S Allen	Art Unit 2872	Page 1 of 1

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	B	US-4,900,112	02-1990	Kawachi et al.	385/14
	C	US-6,411,752	06-2002	Little et al.	385/17
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Chu et al, Wavelength Trimming of a Microring Resonator Filter by Means of a UV Sensitive Polymer Overlay, June 1999, IEEE Photonics Technology Letters, vol. 11 no. 6, pp. 688 - 690.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.